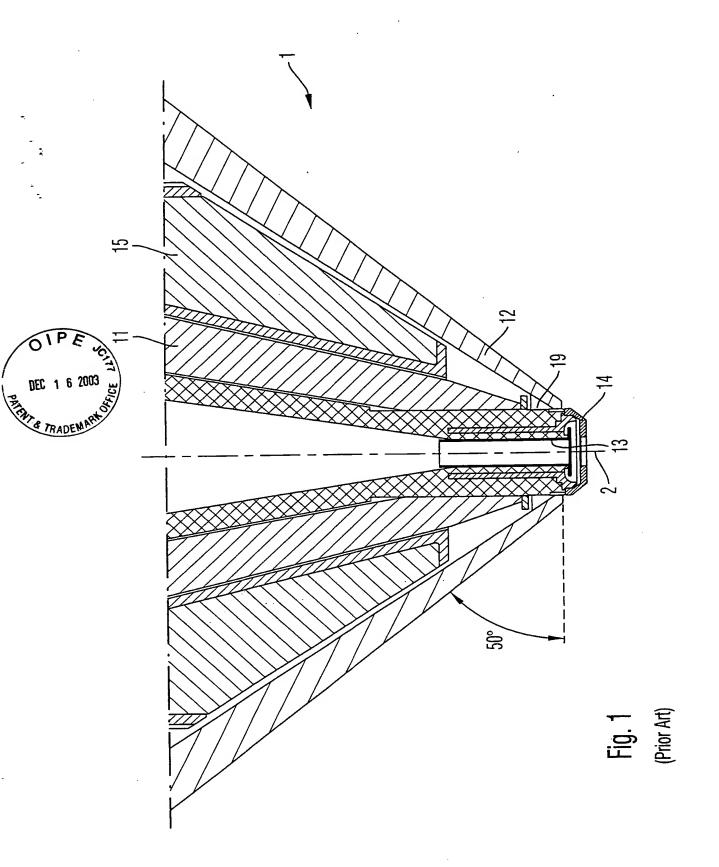
SYSTEM AND ELECTRON MICROSCOPY SYSTEM

INVENTOR(S): DIRK PREIKSZAS ET AL. APPLICATION SERIAL NO: 007413-058

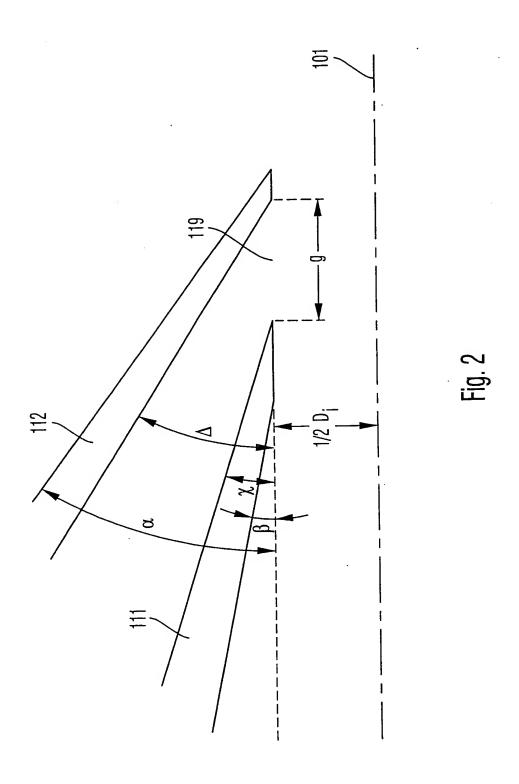
SHEET 1 of 8



SYSTEM AND ELECTRON MICROSCOPY SYSTEM

INVENTOR(S): DIRK PREIKSZAS ET AL. APPLICATION SERIAL NO: 007413-058

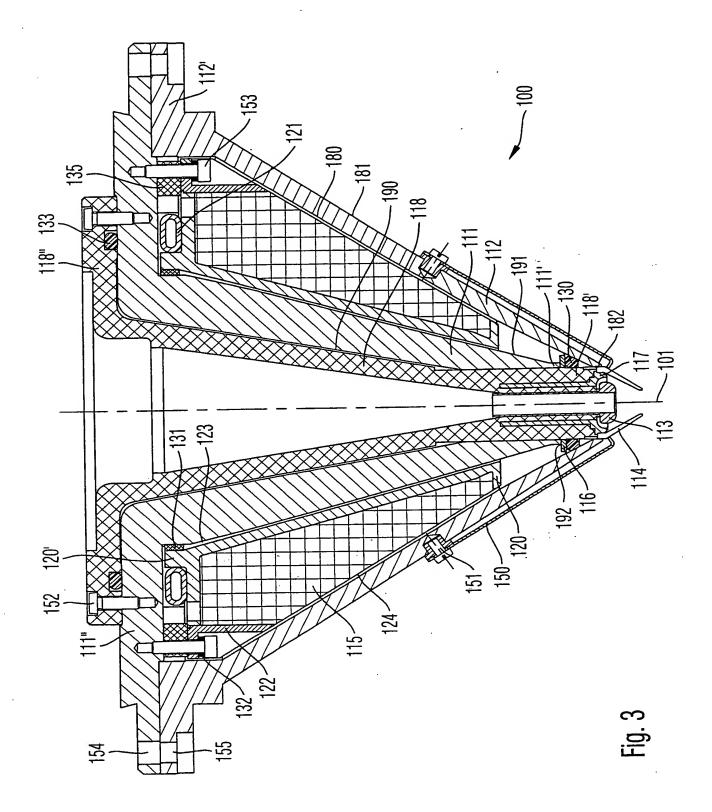
SHEET 2 of 8



APPLN. FILING DATE: JULY 16, 2003
, TITLE: OBJECTIVE LENS FOR AN ELECTRON MICROSCOPY
SYSTEM AND ELECTRON MICROSCOPY SYSTEM

INVENTOR(S): DIRK PREIKSZAS ET AL. APPLICATION SERIAL NO: 007413-058

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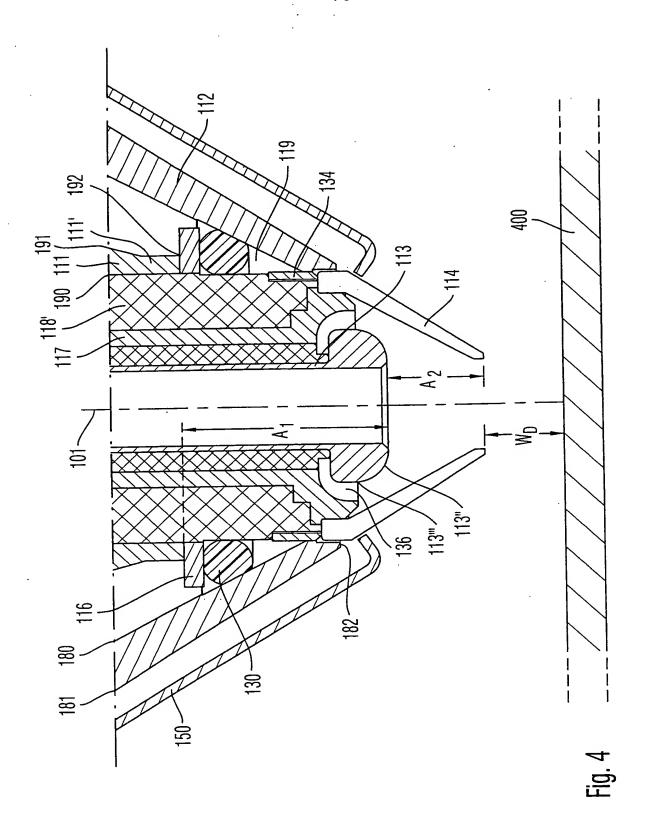


SYSTEM AND ELECTRON MICROSCOPY SYSTEM

INVENTOR(S): DIRK PREIKSZAS ET AL.

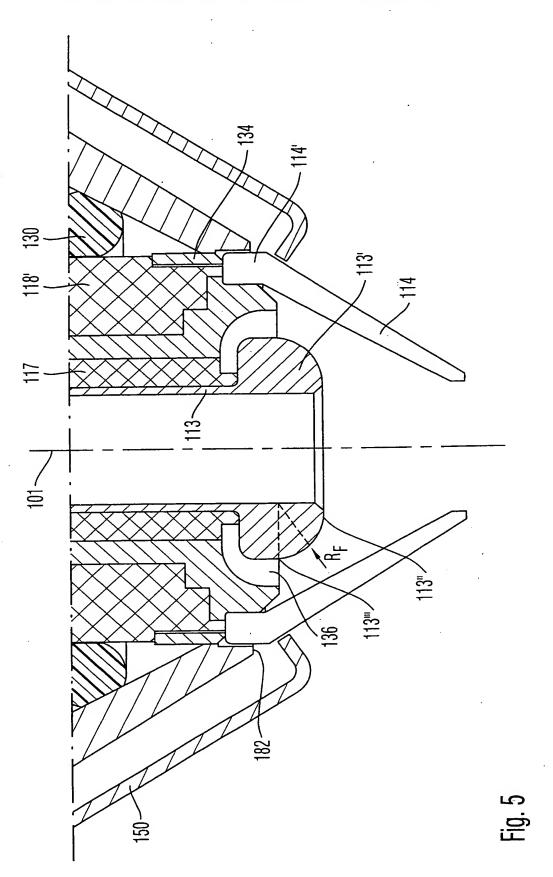
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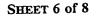


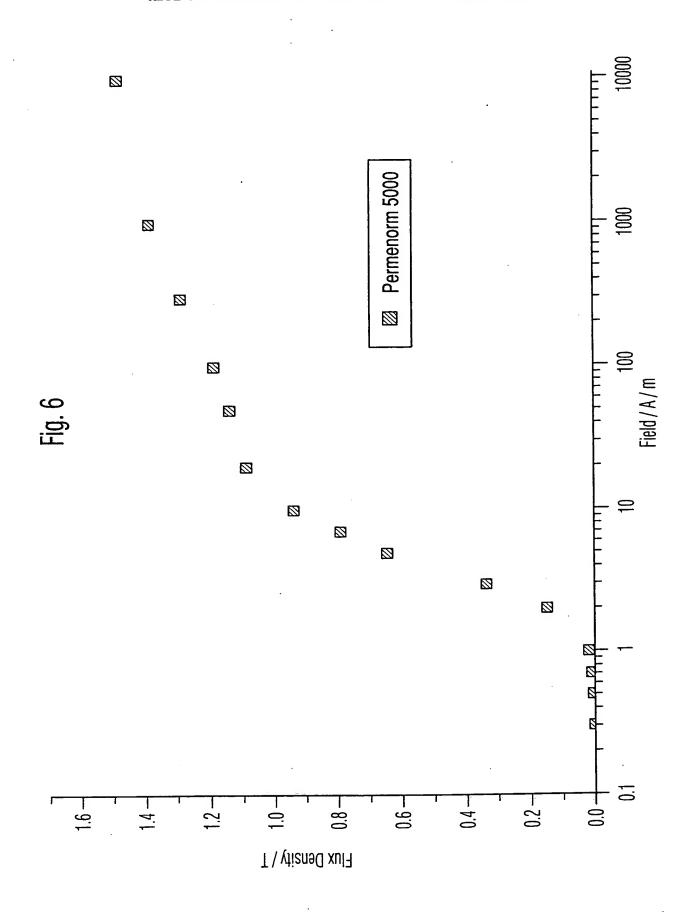
APPLN. FILING DATE: JULY 16, 2003
TITLE: OBJECTIVE LENS FOR AN ELECTRON MICROSCOPY
SYSTEM AND ELECTRON MICROSCOPY SYSTEM
INVENTOR(S): DIRK PREJKSZAS ET AL.

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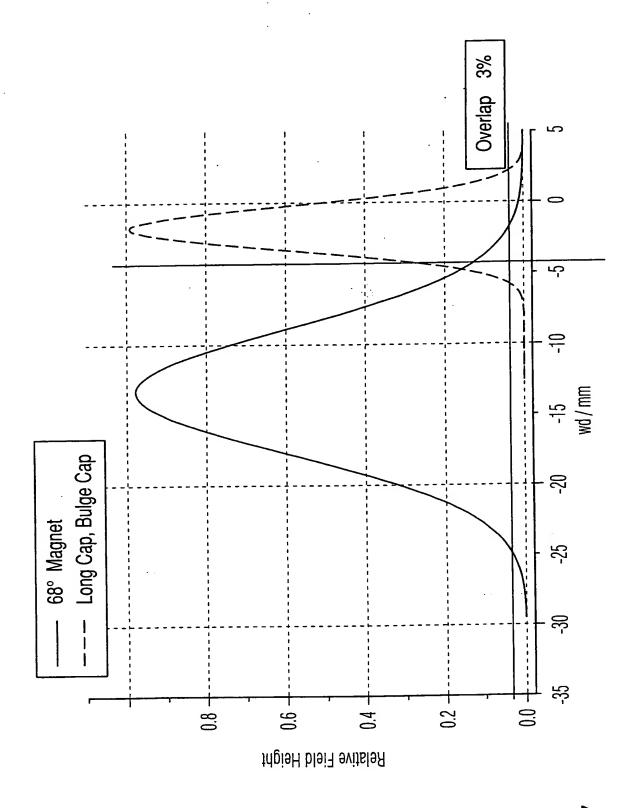
SYSTEM AND ELECTRON MICROSCOPY SYSTEM INVENTOR(S): DIRK PREIKSZAS ET AL. APPLICATION SERIAL NO: 007413-058





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TITLE: OBJECTIVE LENS FOR AN ELECTRON MICROSCOPY
SYSTEM AND ELECTRON MICROSCOPY SYSTEM
INVENTOR(S): DIRK PREIKSZAS ET AL.
APPLICATION SERIAL NO: 007413-058
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APPLN. FILING DATE: JULY 16, 2003
TITLE: OBJECTIVE LENS FOR AN ELECTRON MICROSCOPY
SYSTEM AND ELECTRON MICROSCOPY SYSTEM
INVENTOR(S): DIRK PREIKSZAS ET AL.
APPLICATION SERIAL NO: 007413-058
SHEET 8 0

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